## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Eran Dvir, Eli Haimovich, and Benjamin Shulman

Assignee:

Nova Measuring Instruments, Ltd.

Title:

APPARATUS FOR OPTICAL INSPECTION OF WAFERS DURING

**POLISHING** 

Serial No.:

08/497,382

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Examiner:

E. Morgan

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COMMISSIONER OF PATENTS AND TRADEMARKS

Washington, D. C. 20231

## AMENDMENT UNDER 37 C.F.R. § 1.312(a)

Dear Sir:

Pursuant to 37 C.F.R. §1.312(a) kindly amend the above-identified application as follows:

## IN THE DRAWINGS

Applicants request permission to amend drawing Figures 6, 7, 8, and 9 as submitted with changes as marked up in red ink accompanying the Request to Amend Drawings Under 37 C.F.R. § 1.123. A new set of formal drawings comprising Figures 1-13 is provided which incorporates the changes to Figures 6, 7, 8 and 9 and overcomes the objections raised in the Notice of Draftsperson's Patent Drawing Review.

IN THE SPECIFICATION

Page 2, line , kindly change "is produced found in" to --is--;

Jan Mah

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